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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Satoshi TANAKA et al. : **Mail Stop: PCT**  
Serial No. 10/531,006 : Attorney Docket No. 2005\_0626A  
Filed April 12, 2005 :

FOAM MOLDING METHOD AND APPARATUS  
[Corresponding to PCT/JP03/14315  
Filed November 11, 2003]

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, Applicants request consideration of the reference listed on the attached Form PTO-1449. This reference was cited in the International Search Report submitted with the IDS of April 12, 2005. A copy of the reference "AO" is submitted herewith. Note, the cited reference corresponds to reference "AO" which is listed on the Form PTO-1449 filed April 12, 2005.

***This Supplemental IDS is submitted before the mailing date of the first Office Action, and thus no certification and/or fee is required.***

Respectfully submitted,

Satoshi TANAKA et al.

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## INFORMATION DISCLOSURE STATEMENT

FORM PTO 1449 (modified)

ATTY DOCKET NO.  
2005\_0626ASERIAL NO.  
NEWU.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)APPLICANT  
Satoshi TANAKA et al.FILING DATE  
April 12, 2005

GROUP

Date Submitted to PTO: January 23, 2006

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
	AJ	56-149624	4/1980	JP				
	AK							
	AL							
	AM							
	AN							

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	AO	
	AP	
	AQ	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.